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PATENT  
Attorney Docket No.: 130399

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Jiang Hsieh et al.	:	
		:	Group No.: 2625
Serial No.:	10/749,033	:	
		:	Examiner: Couso, Yon Jung
Filed:	December 30, 2003	:	
		:	
For:	METHODS AND APPARATUS FOR ARTIFACT REDUCTION	:	
		:	

CERTIFICATE OF MAILING

I certify that this correspondence is being deposited with the United States Postal Service as *first class mail* in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 27, 2005.



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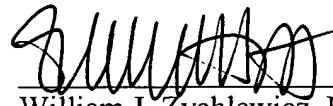
REQUEST FOR STATUS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

On *December 30, 2003*, applicants filed the above-captioned application with the U.S. Patent Office. To date applicants have received no substantive action in this matter. May we please hear from you regarding the current status of this application.

Respectfully submitted,



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